

NOTIFICATION OF CHANGE OF

☒ APPLICANT
☐ INVENTOR

To : Commissioner of
the Korean Industrial Property Office

International Application No. PCT/KR01/00166

Applicant	Name	Korea Advanced institute of Science and Technology et al.		Residence Reg. No.	Country of Nationality	KR	
	Address	#373-1 Kusong-dong, Yusong-gu, Taejon 305-701, Republic of Korea					
Agent	Name	LEE, Jong Il	Agent's Code	9-1998 -000471-4	Tel. No.	+82-2-554-3026	
	Address	#904 Byc Building, 648-1, Yeoksam-dong, Kangnam-ku, Seoul, 135-080, Republic of Korea					
Cause of Change		addition of an applicant					
Contents of Notification	Former	Name	Korea Advanced institute of Science and Technology		Residence Reg. No.	Country of Nationality	KR
		Address	#373-1 Kusong-dong, Yusong-gu, Taejon 305-701, Republic of Korea				
		Name	SUNG, Dan Keun		Residence Reg. No.	Country of Nationality	KR
		Address	#103-1503, Hanwool APT., Shin Sung-Dong, Yusong-Ku, Taejon, 305-345 Republic of Korea				
		Name	PARK, Su Wom		Residence Reg. No.	Country of Nationality	KR
		Address	Department of Electrical Engineering, KAIST, Kusong-Dong, Yusong-Ku, Taejon, 305-701 Republic of Korea				

Contents
of
Notifi-
cation

New

Name	Korea Advanced Institute of Science and Technology	Residence Reg. No.	Country of Nationality	KR
Address	#373-1 Kusong-dong, Yusong-gu, Taejon 305-701, Republic of Korea			
Designated State(s)	all designated States except. the United States of America			
Name	Electronics and Telecommunications Research Institute	Residence Reg. No.	Country of Nationality	KR
Address	#161, Gajong-dong, Yusong-gu, Daejon, 305-350, Republic of Korea			
Designated State(s)	all designated States except. the United States of America			
Name	SUNG, Dan Keun	Residence Reg. No.	Country of Nationality	KR
Address	#103-1503, Hanwool APT., Shin Sung-Dong, Yusong-Ku, Taejon, 305-345 Republic of Korea			
Designated State(s)	the United States of America only			
Name	PARK, Su Wom	Residence Reg. No.	Country of Nationality	KR
Address	Department of Electrical Engineering, KAIST, Kusong-Dong, Yusong-Ku, Taejon, 305-701 Republic of Korea			
Designated State(s)	the United States of America only			

Submitted hereby is a notification pursuant to Article 82 of the
Enforcement Regulations of the Patent Law.

Date(day/month/year) February 26, 2002

Agent LEE, Jong Il



※ Attached Document(s)

1. A copy of the document(s) substantiating the contents of notification (in case of, notification by new applicant)
2. A certified copy of seal impression (in case of notification by new applicant)
3. A copy of the document(s) substantiating the power of attorney, if any

Power of Attorney

Agent

Name : LEE, Jong Il
Address : #904 Byc Building
648-1, Yeoksam-dong, Kangnam-ku,
Seoul 135-080, Republic of Korea

I/We, the understanding, do hereby appoint the above-identified agent as my/our agent to act for me/us in all proceedings concerning the following International Application.

International Application No. : PCT/KR01/00166

Title of Invention :

MULTI-DIMENSIONAL ORTHOGONAL RESOURCE HOPPING
MULTIPLESING COMMUNICATIONS METHOD AND APPARATUS

Dated this 20th of February 2002

Applicant Name : Electrons and Telecommunications Research Institute
Representative : Oh, Gil Roh
Address : #161, Gajang-dong, Yuseong-gu, Daejeon
305-350 Republic of Korea



ASSIGNMENT

ASSIGNOR :

TITLE : Korea Advanced Institute of Science and Technology(KAIST)
(an institute organized and existing under the laws of Korea)
ADDRESS : #373-1, KUSONG-DONG, YUSONG-KU, TAEJON, 305-701.
REPUBLIC OF KOREA

ASSIGNEE :

TITLE : Electrons and Telecommunications Research Institute (ETRI)
(an institute organized and existing under the laws of Korea)
ADDRESS : #161, GAJANG-DONG, YUSONG-KU, TAEJON, 305-350
REPUBLIC OF KOREA

PCT INTERNATIONAL PATENT APPLICATION :

PCT International Patent No. : PCT/KR01/00166
PCT International Patent Filing Date : 2001. 02. 06
Title of Invention : Multi-dimensional orthogonal resource hopping multiplexing
Communications method and apparatus

ASSIGNOR assigns the partial right to acquire the patent for said PCT application to ASSIGNEE.

February 20, 2002

Assignor' Signature :

Korea Advanced Institute of Science and Technology
Hong Chang Sun

